



A handwritten signature in black ink, appearing to read "Cynthia L. Hayden".

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Kramadhati V. Ravi et al. § Art Unit: 2826
Serial No.: 10/809,243 § Examiner: Tuan N. Quach
Filed: March 25, 2004 § Atty Docket: ITL.1126US
For: Low Dielectric Constant § P19032
Carbon Films § Assignee: Intel Corporation
§

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement mailed March 2, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: <u>March 11, 2005</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
Cynthia L. Hayden